

	Application No.	Applicant(s)
Notice of Allowability	09/921,456	BROSNIHHAN ET AL.
	Examiner	Art Unit
	Stephen W. Smoot	2813
The MAILING DATE of this communication appears on the cover sheet with the correspondence address All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS. This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308.		
1. A This communication is responsive to <u>applicant's amendment</u>	ent filed on 04 November 2005.	
2. ☑ The allowed claim(s) is/are <u>1-3,5,6 and 8-22</u> .		
 Acknowledgment is made of a claim for foreign priority una)	e been received. e been received in Application No.	
Applicant has THREE MONTHS FROM THE "MAILING DATE" of this communication to file a reply complying with the requirements noted below. Failure to timely comply will result in ABANDONMENT of this application. THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		
4. A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which giv		
 5. CORRECTED DRAWINGS (as "replacement sheets") must be submitted. (a) including changes required by the Notice of Draftsperson's Patent Drawing Review (PTO-948) attached 1) hereto or 2) to Paper No./Mail Date (b) including changes required by the attached Examiner's Amendment / Comment or in the Office action of Paper No./Mail Date Identifying indicia such as the application number (see 37 CFR 1.84(c)) should be written on the drawings in the front (not the back) of each sheet. Replacement sheet(s) should be labeled as such in the header according to 37 CFR 1.121(d). 6. DEPOSIT OF and/or INFORMATION about the deposit of BIOLOGICAL MATERIAL must be submitted. Note the attached Examiner's comment regarding REQUIREMENT FOR THE DEPOSIT OF BIOLOGICAL MATERIAL. 		
Attachment(s) 1. Notice of References Cited (PTO-892) 2. Notice of Draftperson's Patent Drawing Review (PTO-948) 3. Information Disclosure Statements (PTO-1449 or PTO/SB/C Paper No./Mail Date	6. Interview Summa Paper No./Mail D 7. Examiner's Amen 8. Examiner's Stater 9. Other	oate
Stephen W. Smoot Patent Examiner Art Unit 2813		

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This Office action is in response to applicant's amendment filed on 04 November 2005.

EXAMINER'S AMENDMENT

- 1. An examiner's amendment to the record appears below in order to include Figure 1d and Figure 4m in the Brief Description of the Drawings. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.
- 2. The application has been amended as follows:

In the Specification:

On page 5, line 22, change "Figures 1a-1c" to --Figures 1a-1d--; and On page 6, line 5, change "Figures 4a-4I" to --Figures 4a-4m--.

- 3. Claims 1-3, 5-6, 8-22 are allowed.
- 4. The following is an examiner's statement of reasons for allowance:

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- Claims 1-3, 5-6, 8-16, 18-22 are allowed because the prior art of record does not teach or suggest, in combination with the other claim limitations, a method of fabricating a microelectromechanical system that includes providing a substrate with a handle layer of silicon, a device layer of silicon, and a sacrificial layer of silicon disposed between the handle layer and the device layer, wherein the handle layer is separated from the sacrificial layer with a first dielectric layer and the sacrificial layer is separated from the device layer with a second dielectric layer, combined with the steps of forming a micromechanical structure in the device layer and removing at least a portion of the sacrificial layer to release the micromechanical structure; and
- Claim 17 is allowed because the prior art of record does not teach or suggest, in combination with the other claim limitations, a method of fabricating a microelectromechanical system that includes providing a substrate with a handle layer of silicon, a device layer of silicon, and a sacrificial layer of silicon disposed between the handle layer and the device layer, wherein the sacrificial layer is created by bonding a first silicon-on-insulator wafer and the device layer is created by bonding a second silicon-on-insulator wafer, combined with the steps of forming a micromechanical structure in the device layer and removing at least a portion of the sacrificial layer to release the micromechanical structure.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably

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accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

5. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Stephen W. Smoot whose telephone number is 571-272-1698. The examiner can normally be reached on M-F (8:00 am to 4:30 pm).

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Carl Whitehead, Jr. can be reached on 571-272-1702. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).